NOV 1 4 2006 BY

PATENT Attorney Docket No. 07553.0044-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:	
Hideki TANAKA) Group Art Unit: 2878
Application No.: 10/644,745) Examiner: J. Lee
Filed: August 21, 2003))
For: PLASMA LEAK MONITORING METHOD, PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD) Confirmation No.: 6213)
Commissioner for Patents	

P.O. Box 1450 Alexandria, VA 22313-1450

11/15/2006 MBERHE 00000089 10644745

81 FC:1866

180.00 OP

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(c)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(c), applicant brings to the attention of the Examiner the documents on the attached listing. This Information Disclosure Statement is being filed after the events recited in Section 1.97(b) but, to the undersigned's knowledge, before the mailing date of either a Final action, Quayle action, or a Notice of Allowance. Under the provisions of 37 C.F.R. § 1.97(c), this Information Disclosure Statement is accompanied by a fee of \$180.00 as specified by Section 1.17(p).

Copies of the listed foreign and non-patent literature documents are attached.

Applicant respectfully requests that the Examiner consider the listed documents and indicate that they were considered by making appropriate notations on the attached form.

With respect to the listed documents which are not in the English Language, Applicants submit the following remarks:

11.415/2006 HERRE 00000087 10644745

01 EC:1806-

40 BB.081

U.S. Application No. 10/644,745 Attorney Docket No. 07553.0044-00

1. JP 64-081197: An English language abstract of this document accompanies this

disclosure.

2. JP 2000-100795: An English language abstract of this document accompanies this

disclosure.

3. JP 2001-319922: An English language abstract of this document accompanies this

disclosure.

This submission does not represent that a search has been made or that no better art

exists and does not constitute an admission that each or all of the listed documents are material

or constitute "prior art." If the Examiner applies any of the documents as prior art against any

claims in the application and Applicant determines that the cited documents do not constitute

"prior art" under United States law, Applicant reserves the right to present to the Office the

relevant facts and law regarding the appropriate status of such documents.

Applicant further reserves the right to take appropriate action to establish the

patentability of the disclosed invention over the listed documents, should one or more of the

documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the

fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,

GARRETT & DUNNER, L.L.P.

Dated: November 14, 2006

By: /David W. Hill/

David W. Hill

Reg. No. 28,220

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IDS Form PTO/SB/08: Substitute for form 1449A/PTO			omplete if Known		
		/	The s	plication Number	10/644,745
INFO	DRMATION D	ISCLOSU	REMADE	Filing Date	August 21, 2003
STATEMENT BY APPLICANT		First Named Inventor	Hideki TANAKA		
		Art Unit	2878		
	(Use as many sheets	as necessary)		Examiner Name	J. Lee
Sheet	1	of	1	Attorney Docket Number	07553.0044-00

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Cite	Document Number	Issue or	Name of Patentee or	Pages, Columns, Lines, Where	
No.	Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear	
	US-				
	US-				
	Cite No. ¹	Cite No. 1 Number Number Number-Kind Code ² (if known) US-	Cite No. 1	Cite No. 1	

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
	1	JP 64-081197	03-27-1989	Hitachi Ltd	- 1	Abstract
	2	JP 2000-100795	04-07-2000	Seiko Epson Corp.		Abstract
	3	JP 2001-319922	11-16-2001	NEC Corp.		Abstract
	4	WO 00/03421	01-20-2000	Applied Materials Inc.		n/a

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶		
	5	English Abstract of JP 64-081197			
	6	English Abstract of JP 2000-100795			
	7	English Abstract of JP 2001-319922			

Examiner	Date	
	Date	
Signature	Considered	
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